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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PRIORITY** Application Serial No. .... 10/226,005  
Confirmation No. .... unknown  
**PRIORITY** Filing Date ..... August 21, 2002  
Inventor..... H. Daniel Dulman et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... unknown  
Examiner ..... unknown  
Attorney's Docket No. .... MI22-2514  
Customer No. .... 021567  
Title: Methods Of Forming Aligned Structures With Radiation-Sensitive Material

**PRELIMINARY AMENDMENT**

To:           Mail Stop PATENT APPLICATION  
              Commissioner for Patents  
              P.O. Box 1450  
              Alexandria, VA 22313-1450

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**AMENDMENTS**